[TE2] Plasma for Nanomaterial Processing $ \mathrm{II} $	
Date / Time	July 26 (Thu.), 2018 / 15:30-17:20
Place	Room E (#107~108)
Session Chair(s)	Hyung-Mo Jeong (Kangwon Nat'l Univ., Korea)

TE2-1 [Invited] 15:30-16:00

Bottom-Up Synthesis of Atomically-Precise Low-Dimensional Nanocarbon Materials by Nanoscale Plasma Processing

Toshiaki Kato and Toshiro Kaneko *Tohoku Univ., Japan*

TE2-2 16:00-16:20

Heterogeneity of Hard Skin Layer in Wrinkled PDMS Surface Fabricated by Ar Ion Beam Irradiation Seunghun Lee, Eunyeon Byeon, Sunghoon Jeong, and Do-Geun Kim KIMS, Korea

TE2-3 16:20-16:40

Synthesis of Metal-Boride Nanoparticles Using Triple Thermal Plasma Jet System Minseok Kim¹, Jeong-Hwan Oh¹, Tae-Hee Kim², Yong Hee Lee¹, Seung-Hyun Hong¹, and Sooseok Choi¹ Jeju Nat'l Univ., Korea, ²Inst. for Nuclear Science and Tech., Korea

TE2-4 16:40-17:00

Preparation of Catalyst with Microwave Induced Plasma Jet Combined with Spouted Bed Jai Young Chung, Satoshi Kodama, and Hidetoshi Sekiguchi *Tokyo Inst. of Tech., Japan*

TE2-5 17:00-17:20

Surface Treatment of Two-Dimensional $Ti_3C_2T_x$ Using Radio-Frequency Remote Plasma System Byeong-Joo Lee, Yoon-Jeong Chae, Yong-Hee Lee, and Chi Won Ahn Nat'l NanoFab Center, Korea